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Application/Control No.	Applicant(s)/Patent under Reexamination	
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Class	Subclass	Date	Examiner
375	229-236 & Iterative	6/30/2005	JP
	316	6/30/2005	JP
	346	6/30/2005	JP
	348	6/30/2005	JP
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SEARCH NOT (INCLUDING SEARCH)
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East USPAT/USPGPUB EPO/JPO	6/30/2005	JP
Inventor Name Search	6/30/2005	· JP
IEEE iterative AND channel AND estimate	6/30/2005	JP
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